## **Electronic Supplementary Information**

## Influence of solution-deposited rutile layer on morphology of TiO<sub>2</sub> nanorod arrays and performance of nanorod-based dye-

## sensitized solar cells

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**Figure S1**. Raman spectrum of the rutile seed layer deposited onto conducting glass *via* hydrolysis of TiCl<sub>4</sub> solution.

**Table S1**. Structural properties of  $TiO_2$  NR arrays grown on bare FTO and  $TiO_2$  seed layers which were deposited from  $TiCl_4$  precursor solutions with concentrations of 0.05, 0.2, and 0.4 M, respectively.

samples	The density of TiO <sub>2</sub> NRs (number μm <sup>-2</sup> )	The length of TiO <sub>2</sub> NRs (μm)	The diameter of TiO <sub>2</sub> NRs (nm)
FTO-NR	24±4	1.2±0.05	82±25
0.05 M-NR	39±8	$1.3 \pm 0.05$	80±24
0.2 M-NR	58±8	1.3±0.06	60±10

0.4 M-NR	99±13	$1.5 \pm 0.06$	$52\pm9$



**Figure S2**. Top-view SEM images of the  $TiO_2$  NR arrays grown at 150 °C for 30 min on bare FTO (a) and  $TiO_2$  seed layers which were deposited from  $TiCl_4$  precursor solutions with concentrations of 0.05 (b), 0.2 (c), and 0.4 M (d), respectively.

**Table S2**. Series resistance  $(R_s)$ , charge transfer resistance (R1), interfacial recombination resistance (R2) from EIS spectra calculated by equivalent circuit as shown in Fig.8.

samples	$\mathrm{R}_{\mathrm{s}}\left(\Omega ight)$	R1 (Ω)	R2 (Ω)	
0.05 M-NR	30.74	1.14	331.2	
0.2 M-NR	31.33	1.31	304.6	
0.4 M-NR	38.45	2.89	237.4	